

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. <b>277078US0PCT</b>		SERIAL NO. <b>10/550,534</b>	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT <b>Kentarou TAMAKI, et al.</b>			
				FILING DATE <b>September 22, 2005</b>		GROUP <b>2874</b>	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
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	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES                      NO		
	AO	JP 2000-66051	3/3/2000	Japan (with English Abstract)			X
	AR	JP 2001-83342	3/30/2001	Japan (with English Abstract)			X
	AQ	JP 63-194206	8/11/1988	Japan			X
	AR	JP 61-260208	11/18/1986	Japan			X
	AS	WO 03/010603 A1	2/6/2003	WIPO (with English Abstract)			X
	AT	JP 10-268158	10/9/1998	Japan (with English Abstract)			X
	AU	CN 1285667 A	2/28/2001	China			X
	AV						
<b>OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
	AW	Kentarou TAMAKI, et al. " Photolithographic Properties of Photosensitive Sol-gel Materials and their Application to Optical Waveguides", Journal of Photopolymer Science and Technology Volume 15, Number 1, 2002, Pages 103-108					
	AX						
	AY						
	AZ					<input type="checkbox"/> Additional References sheet(s) attached	
Examiner					Date Considered		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							